



## Certificate of Publication

This certifies that the research paper entitled “**Design of Semiconductor Manufacturing Environment Monitoring System Based on the IoT**” authored by “**Hongyu Yang**” was reviewed by experts in this research area and accepted by the board of “Quest Journals Publication” which has published in “**Quest Journal of Research in Mechanical Engineering**”, ISSN (Online): 2321-8185, Volume-9, Issue-11, Page No.: 01-14, [2023].

Article is available online at <http://www.questjournals.org/jrme/archive.html>

Impact Factor of the Journal is : 5.96 Journal is Peer Reviewed Refereed Journal.

You may contact to Journal for any query at [quest@editormails.com](mailto:quest@editormails.com)



Managing Editor

Quest Journals Inc.

Mail id: [quest@editormails.com](mailto:quest@editormails.com)

Website: [www.questjournals.org](http://www.questjournals.org)



## Certificate of Publication

This certifies that the research paper entitled “**Design of Semiconductor Manufacturing Environment Monitoring System Based on the IoT**” authored by “**Yanting Ni**” was reviewed by experts in this research area and accepted by the board of “Quest Journals Publication” which has published in “**Quest Journal of Research in Mechanical Engineering**”, ISSN (Online): 2321-8185, Volume-9, Issue-11, Page No.: 01-14, [2023].

Article is available online at <http://www.questjournals.org/jrme/archive.html>

Impact Factor of the Journal is : 5.96 Journal is Peer Reviewed Refereed Journal.

You may contact to Journal for any query at [quest@editormails.com](mailto:quest@editormails.com)



Managing Editor  
Quest Journals Inc.  
Mail id: [quest@editormails.com](mailto:quest@editormails.com)  
Website: [www.questjournals.org](http://www.questjournals.org)